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| Application Number     | 10/765,904       |
| Confirmation Number    | 2613             |
| Filing Date            | January 29, 2004 |
| First Named Inventor   | Markus MENGEL    |
| Art Unit               | 2878             |
| Examiner Name          | Samuel A. TURNER |
| Attorney Docket Number | Q79656           |

~~U.S. GOVERNMENT DOCUMENTS~~

## FOREIGN PATENT DOCUMENTS

## NON PATENT LITERATURE DOCUMENTS

| Examiner Initials* | Cite No. <sup>1</sup> | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published. | Translation <sup>6</sup> |
|--------------------|-----------------------|--|--------------------------|
| /SAT/              |                       | MICHAEL TOTZECK, ET AL, "HIGH-RESOLUTION MEASUREMENT OF 2D-MICROSTRUCTURES BY MEANS OF JONES-MATRIX MICROSCOPY", INSTITUT FÜR  |                          |
|                    |                       | TECHNISCHE OPTIK, UNIVERSITÄT STUTTGART STUTTGART, GERMANY, PAGES 1-4  | No date                  |
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| <b>Examiner Signature</b> | /Samuel A. Turner/ | <b>Date Considered</b> | 06/15/2007 |
|---------------------------|--------------------|------------------------|------------|

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